



IPSW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

OKAZAKI

Atty. Ref.: 1035-500

Serial No. 10/801,032

Group: 2811

Filed: March 16, 2004

Examiner:

For: FABRICATION METHOD OF SEMICONDUCTOR  
LASER DEVICE

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Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**STATUS INQUIRY**

An application was filed on March 16, 2004. However, since then applicant has not received any Official Action from the Patent Office regarding the application.

Inquiry is made as to when an Action will be forthcoming. **Please direct any response to this inquiry to Linda Hull at telephone number (703) 816-4127.**

Respectfully submitted,  
**NIXON & VANDERHYE P.C.**

September 15, 2005

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